IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Osamu NAKAMURA

Serial No.: 10/809,118

Filed: March 25, 2004

Art Unit: 2814

Examiner: Hoai V. Pham

Confirmation No: 7733

For: SEMICONDUCTOR DEVICE AND
MANUFACTURING METHOD THEREOF

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. §1.97, Applicant hereby calls the Examiner's attention to documents listed on the attached form, which documents may be material to the examination of this application. Pursuant to 37 CFR §1.98(a)(2)(i), copies of cited US patent and US patent application publications are not submitted herewith.

No inference should be drawn that the attached list sets forth a comprehensive investigation of the prior art, that any or all are pertinent to the invention, or that any apparatus disclosed is equivalent to the subject invention.

The citation of the above-discussed documents is not to be construed as an assertion that more pertinent art could not possibly be in existence. Citation of any document herein is not to be construed as an admission that any subject matter disclosed in the document is necessarily within the inventive field of endeavor, that any disclosure is necessarily prior in time to a particular date which may be relevant to the instant patent application, and/or that any disclosure is otherwise necessarily prior art with respect to the instant invention.

Applicant also respectfully reserves the right to later set forth how the instant invention is distinguished over the disclosure of any document or other art, including the disclosure of those documents discussed herein, that may be cited by the Examiner in rejecting a claim in the instant patent application.

FEE

As a first office action of merit, notice of allowance or issue fee notification has not been received in this case,

Applicant does not believe that a fee is due for this IDS.

However, if any such fee is required, please charge our Deposit Account No. 50/1039.

Respectfully submitted,

Mark J. Murphy

Registration No.: 34,225

COOK, ALEX, McFARRON, MANZO, CUMMINGS & MEHLER, LTD. 200 West Adams Street Suite 2850 Chicago, Illinois 60606 (312) 236-8500

Customer no. 000026568

LIST OF PUBLICATIONS CITED BY THE APPLICANT Applicant Osamu NAKAMURA Filing Date March 25, 2004 US PATENT DOCUMENTS Examiner Document Number Date Name Serial No. 10/809,118 Examiner Name Hoai V. Pham Group 2814

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